

**REQUEST
FOR
CONTINUED EXAMINATION (RCE)
TRANSMITTAL**

This is a Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 of the above-captioned application.

Application Number 767,659
Filing Date January 22, 2001
First Named Inventor Richard N. SAVAGE
Group Art Unit 3652
Examiner Name FOX, Charles A.
Attorney Docket No. A-67736-1/MSS/TJH

MAIL STOP RCE

Commissioner for Patent
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAIL (37 CFR 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: MAIL STOP RCE, Commissioner for Patent, P.O. Box 1450, Alexandria, VA 22313-1450 on April 29, 2003

Signed

Laura Lee Mosier

1. Submission required under 37 C.F.R. § 1.114

- a. ☒ Previously submitted
- i. ☒ Consider the amendment(s)/reply under 37 C.F.R. § 1.116 previously filed on March 31, 2003 (Any unentered amendment(s) referred to above will be entered.)
- ii. ☐ Consider the arguments in the Appeal Brief or Reply Brief previously filed on _____
- iii. ☐ Other: _____
- b. ☒ Enclosed
- i. ☐ Amendment/Reply
- ii. ☐ Affidavit(s)/Declaration(s)
- iii. ☐ Information Disclosure Statement (including Form PTO-1449 and References)
- iv. ☒ Other: **Copy of the unentered amendment filed on March 31, 2003.**

RECEIVED

JUN 17 2004

GROUP 3600

2. Miscellaneous

- a. ☐ Suspension of action on the above-captioned application is requested under 37 C.F.R. § 1.103(c) for a period of _____ months. (Period of suspension shall not exceed three months; Fee under 37 C.F.R. § 1.17(i) required.)
- b. ☐ Other: _____

3. Fees The RCE fee under 37 C.F.R. § 1.17(e) is required by 37 C.F.R. § 1.114 when the RCE is filed.

- a. ☒ The Fees are calculated as follows:
- | | AMOUNT | <input checked="" type="checkbox"/> Large Entity | <input type="checkbox"/> Small Entity |
|--|-----------|---|--|
| i. <input checked="" type="checkbox"/> RCE BASIC FEE | \$ 750.00 | \$ 750.00 | \$ 375.00 |
| ii. <input checked="" type="checkbox"/> EXTENSION FEES | \$ 110.00 | One-Month \$ 110.00
Two-Month 410.00
Three-Month 930.00
Four-Month 1450.00
Five-Month 1970.00 | \$ 55.00
205.00
465.00
725.00
985.00 |
| iii. <input type="checkbox"/> OTHER | \$ | \$ 18.00 | \$ 9.00 |
- b. ☒ Check in the amount of \$ 860.00 is enclosed. The Commissioner is hereby authorized to charge any variance between the amount enclosed and the Patent Office charges to Deposit Account No. 50-2319 (A-67736-1/MSS/TJH(463035-19)).
- c. ☐ The Commissioner is hereby authorized to charge the fees as indicated above, charge any variance or credit any overpayments, to Deposit Account No. 50-2319.

SUBMITTED BY

Typed or Printed Name **Tianjun Hou**

Signature

Tianjun Hou

Date

April 29, 2003

Complete (if applicable)

Registration No. **51,821**

COPY

Dorsey & Whitney LLP
 850 Hansen Way
 Suite 200
 Palo Alto, CA 94304-1017

BANK OF AMERICA
 NATIONAL ASSOCIATION
 CHICAGO, IL 60697
 2-3710

5569

4/29/2003

PAY TO THE ORDER OF Commissioner Of the U.S. Patent And Trademark Office

\$ **860.00

Eight Hundred Sixty and 00/100

DOLLARS

MEMO A-67736-1/TJH 463035-00019 (2841)


⑈005569⑈ ⑆071000039⑆ 86660⑈ 17115⑈

In the United States Patent and Trademark Office

File No.: A-67736-1/5702/TJH	U.S. Application No. 09/767,659	Filing Date: January 22, 2001
Date Due: April 30, 2003	Date Mailed: April 29, 2003	Express Mail No.: n/a
Applicant: Richard N. SAVAGE et al.		ASML
Entitled: Semiconductor Wafer Processing system with Vertically-Stacked Process Chambers and Single-Axis Dual-Wafer Transfer System		
Enclosures: [X] RCE Transmittal, 1 page; [X] Copy of previously filed Response to pending OA, dated March 31, 2003; 9 pages; [X] Check No. 5569 for \$860 RCE filing fees & one month extension fee (LARGE ENTITY) [X] and this postcard.		Official Use Only!

COPY

In the United States Patent and Trademark Office

File No.: A-67736-1/5702/TJH	U.S. Application No. 09/767,659	Filing Date: January 22, 2001
Date Due: April 30, 2003	Date Mailed: April 29, 2003	Express Mail No.: n/a
Applicant: Richard N. SAVAGE et al.		ASML
Entitled: Semiconductor Wafer Processing system with Vertically-Stacked Process Chambers and Single-Axis Dual-Wafer Transfer System		
Enclosures: [X] RCE Transmittal, 1 page; [X] Copy of previously filed Response to pending OA, dated March 31, 2003; 9 pages; [X] Check No. 5569 for \$860 RCE filing fees & one month extension fee (LARGE ENTITY) [X] and this postcard.		Official Use Only! 

RECEIVED

JUN 17 2004

GROUP 3600